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Substitute for form 1446/PTO			Complete if Known Application Number 09/674,090 Filing Date March 1, 2001 First Named Inventor Yoav Elchen Art Unit 1637 Examiner Name Jeffrey Siew Attorney Docket Number 18363.0002/P002	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				
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Examiner Initials ¹	Cite No. ²	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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		Country Code ⁵ -Number ⁶ -Kind Code ⁶ (if known)				
		WO 98/53841	12-1998	WIPO		
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		WO 99/29711	6-1999	WIPO		
		WO 99/35256	7-1999	WIPO		
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Substitute for form 1449/APTO			Complete if Known Application Number 09/674,090 Filing Date March 1, 2001 First Named Inventor Yoav Eichen Art Unit 1637 Examiner Name Jeffrey Siew Attorney Docket Number 18363.0002/P002	
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OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS						
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				T ¹
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		Klein et al., "An Approach to Electrical Studies of Single Nanocrystals," <u>Appl. Phys. Lett.</u> , 68 (18):2574-2576 (1996)				
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Substitute for form 1449A/PTO				Complete If Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	09/674,090
				Filing Date	March 1, 2001
				First Named Inventor	Yoav Eichen
				Art Unit	1637
				Examiner Name	Jeffrey Siew
Sheet	3	of	3	Attorney Docket Number	18363.0002/P002

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/Angela Bertagna/

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